提出日 特願2000-117502

【書類名】

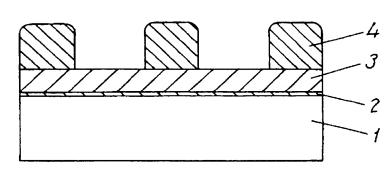
図面

[Name of the Document]

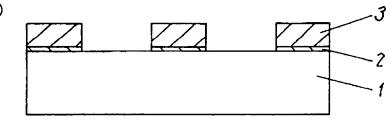
PRAWINGS

【図1】[F19.1]

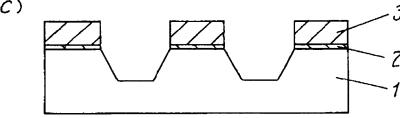




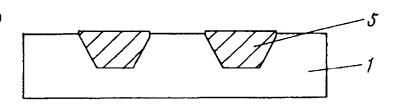
(B)



(*C*)

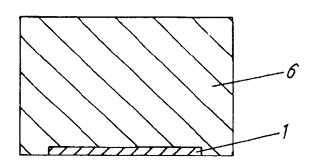


(d)

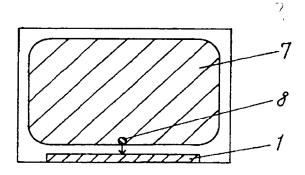


【図2】 (F14.2]

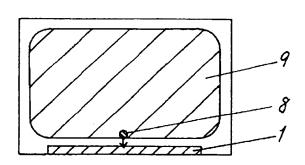




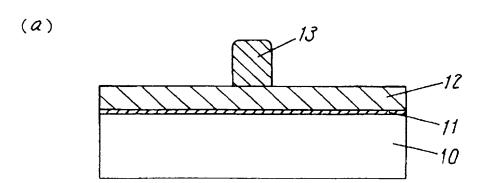
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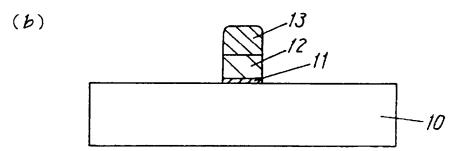


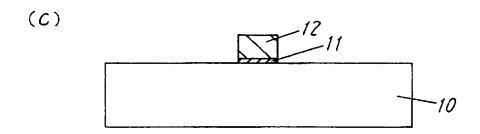
(C)



【図3】 [F19.3]



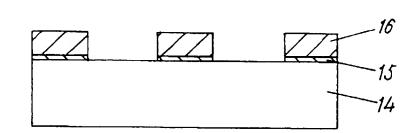


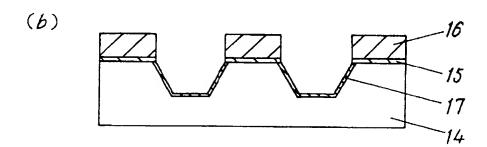


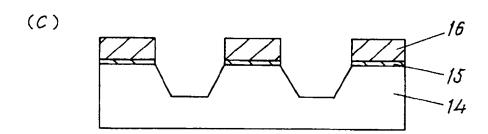
【図4】

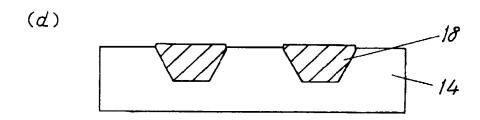


(a)

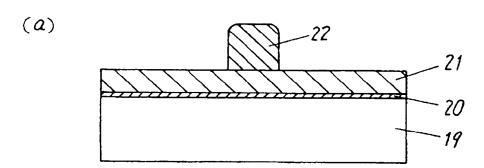


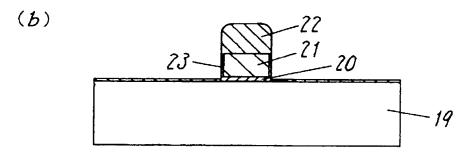


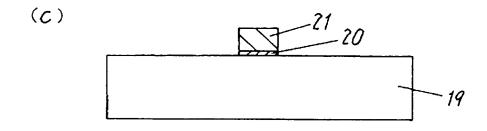




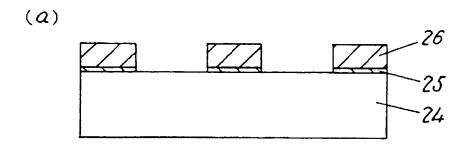
【図5】 [FIG.5]

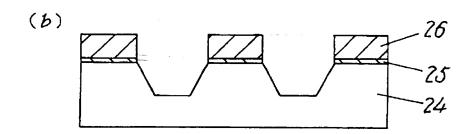


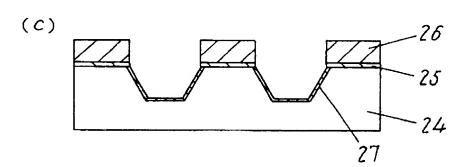


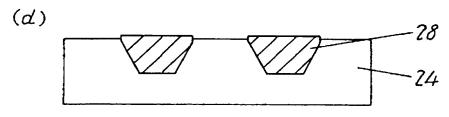


【図6】 [F1G.6]

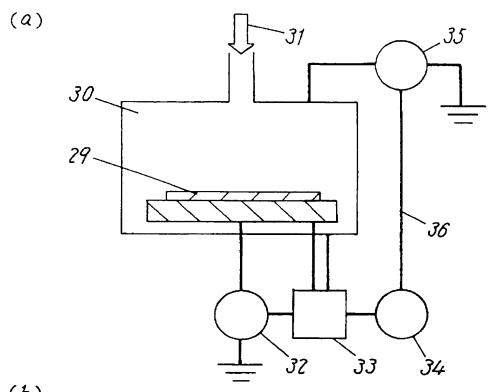








【図7】 [FIG.7]

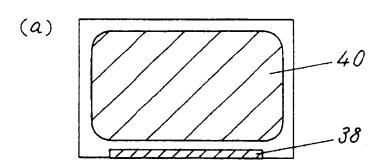


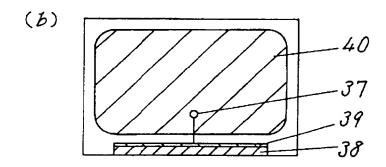
(b) チャンバー内トプロセスガスを導入 Introducing process gas into chamber Effective value of pressure ual to Set value? 在加致加值比認定值と等心? is equal to 正力調整 pressure adjustment Applying bias power バイアス電力をEP加 Effective value of bias power is equal to TAPス電加度效值计認定值增加了 NYTX電力調整 Bias power adjustment set value? Operate timer Effective value of timer is equal to 917-0实为值付設定值と等证 時間経過 Hapsed time set value? Applying source power Effective value of source power is ソース电力調整 Source power equal to set value?

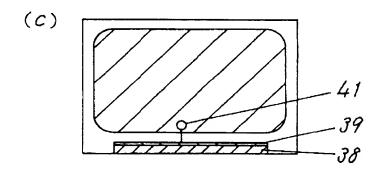
Etching.

adjustment

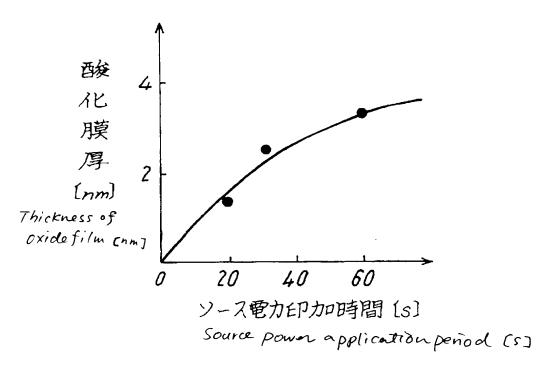
【図8】[F19.8]



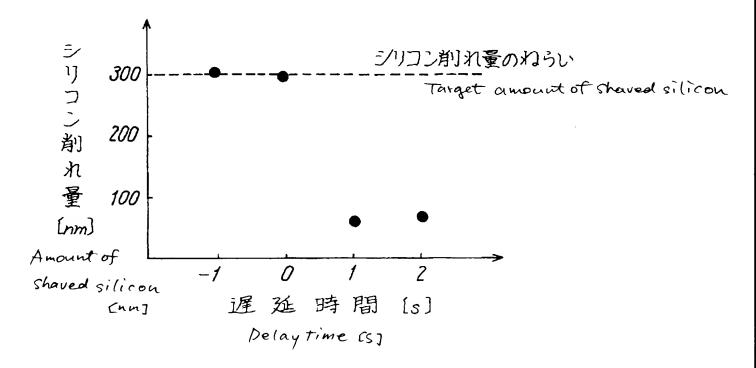




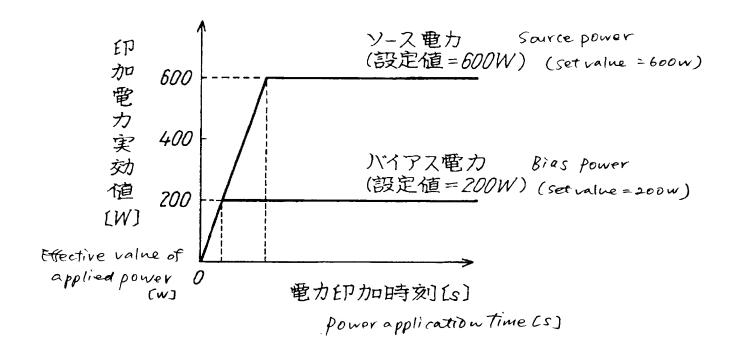
【図9】 (F14.9)



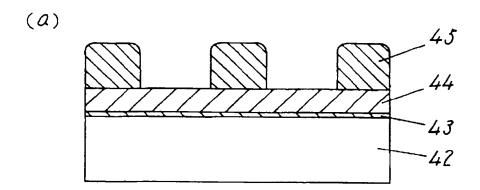
【図10】[F14.10]

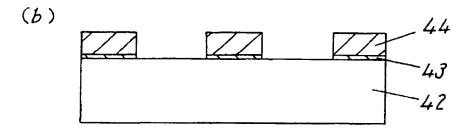


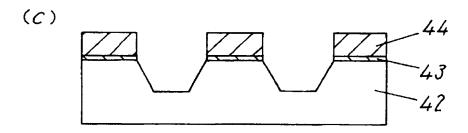
【図11】 (FIG.11]

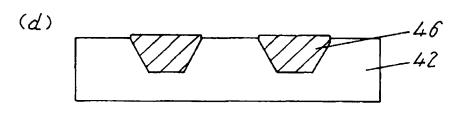


【図12】 [F14.12]

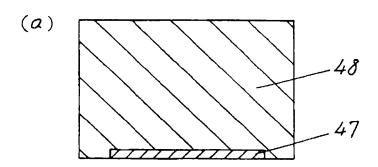


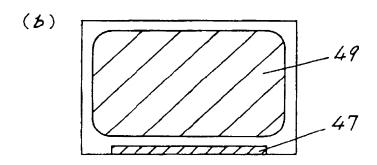


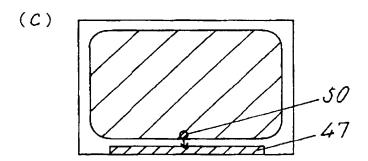




【図13】 [F19.13]







【図14】[FIG.14]

